

<b>Search Notes</b> 	<b>Application/Control No.</b>	<b>Applicant(s)/Patent under Reexamination</b>	
	10/606,348	<b>HONG ET AL.</b>	
	<b>Examiner</b>	<b>Art Unit</b>	
	Ellen Kim	2874	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
385	140, 19	11/14/05	EK